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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masahiro YOSHIKAWA

Group Art Unit: 2828

Application No.: 10/629,777

Filed: July 30, 2003

Docket No.: 116722

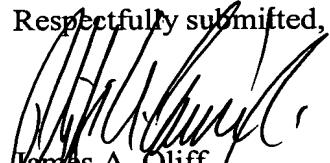
For: METHOD OF FORMING CONDUCTIVE PATTERN SUCH AS ELECTRODE,
SURFACE EMITTING SEMICONDUCTOR LASER USING THIS METHOD AND
MANUFACTURING METHOD FOR THE SAME

STATUS INQUIRY LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please telephone our firm's Patent Application Filing Department at 703-836-6400 with the status of the above-identified patent application, including an indication as to when the next communication can be expected.

Respectfully submitted,

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Date: May 12, 2005

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